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# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

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Complete if Known

Application Number	09/483,881
Filing Date	January 18, 2000
First Named Inventor	Ahn, Kie
Group Art Unit	2812
Examiner Name	Nguyen, Ha

Sheet 1 of 1

Attorney Docket No: 303.672US1

## **US PATENT DOCUMENTS**

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	Filing Date If Appropriate
hm	US-2002/0167089A1	11/14/2002	Ahn, Kie Y., et al.	257	762	05/14/2001
	US-5,240,878	08/31/1993	Fitzsimmons, J., et al.	437	187	04/26/1991
	US-6,065,424	05/23/2000	Shacham-Diamond, Y., et al.	118	696	12/18/1996
	US-6,358,849	03/19/2002	Havemann, R. H., et al.	438	689	12/21/1999
	US-6,552,432	04/22/2003	Farrar, Paul A.	257	751	08/30/2001
	US-6,614,099	09/02/2003	Farrar, Paul A.	257	643	09/04/2001
	US-6,743,716	06/01/2004	Farrar, Paul A.	438	652	07/16/2002
	US-6,756,298	06/29/2004	Ahn, Kie Y., et al.	438	635	08/01/2002

## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	Class	Subclass	T <sup>2</sup>
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## **OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
hm		AMERICAN SOCIETY FOR METALS, "Properties and Selection: Nonferrous Alloys and Pure Metals", <u>Metals Handbook</u> , 9th ed., vol. 2, Metals Park, Ohio,(1979),Table of Contents	
hm		VAN HORN, K. R., "Aluminum Vol. III Fabrication and Finishing", <u>American Society for Metals</u> , Metals Park, OH,(1967),468	

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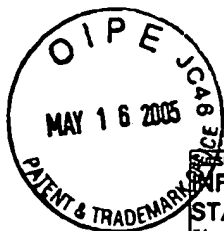
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lm		AMERICAN SOCIETY FOR METALS, "Properties and Selection: Nonferrous Alloys and Pure Metals", Metals Handbook, 9th ed., vol. 2, Metals Park, Ohio,(1979),Table of Contents	
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First Named Inventor Ahn, Kie

Group Art Unit 2812

Examiner Name Nguyen, Ha

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Hm		MURARKA, S. P., et al., "Copper Metallization for ULSI and Beyond". <u>Critical Reviews in Solid State and Materials Sciences</u> , 20(2), (1995), 87-124	

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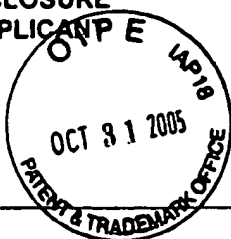
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Wm		BHANSALI, S., et al., "Selective seeding of copper films on polyimide-patterned silicon substrate, using ion implantation", <u>Sensors and Actuators A: Physical</u> , 52(1), (March 1996), 126-131	

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